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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Olivier RAYSSAC et al.

Confirmation No.: 1187

Application No: 10/775,917

Group Art Unit: 2822

Filing Date: February 9, 2004

Examiner: M. Trinh

For: METHOD FOR OBTAINING A SELF-

Atty. Docket No.: 4717-13100

SUPPORTED SEMICONDUCTOR THIN FILM FOR

**ELECTRONIC CIRCUITS** 

## **AMENDMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

In response to the office action dated September 23, 2005, please enter the following amendments and comments into the file of this application.

Amendments to the claims are reflected in the complete listing of all claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.

No fee sheet is believed to be due for the submission of this amendment. Please charge any fees that may be required to Winston & Strawn LLP Deposit Account No. 50-1814.